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Docket No.: OMY-013
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Kunie Ogata et al.

Application No.: 09/963,527

Group Art Unit: 1756

Filed: September 27, 2001

Examiner: J. Ruggles

For: RESIST PATTERN FORMING METHOD
(amended)

AMENDMENT AFTER FINAL ACTION (37 C.F.R. SECTION 1.116)

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated October 8, 2003 (Paper No. 10), finally rejecting claims 16-29, please amend the above-identified U.S. patent application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 4 of this paper.

Remarks/Arguments begin on page 10 of this paper.

An **Appendix** including a substitute specification is attached following page 21 of this paper.

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